

Application No. 10/603,310  
Amdt. dated December 13, 2006  
Reply to Office Action of September 13, 2006

Docket No.: 20793/0204471-US0

Docket No.: 20793/0204471-US0  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Rafael STORZ

Application No.: 10/603,310

Confirmation No.: 5265

Filed: June 25, 2003

Art Unit: 2878

For: METHOD FOR SETTING THE SYSTEM  
PARAMETERS OF A SCANNING  
MICROSCOPE

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Examiner: Bui Pho, Pascal M.

**RESPONSE TO FINAL OFFICE ACTION**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 13, 2006

Sir:

**INTRODUCTORY COMMENTS**

In response to the final office action dated September 13, 2006 received in the above-identified application, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of the claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.